



AF/IFW

XA-10006  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hiroshi Kuroda et al.

Appln. No.: 10/737,119

Group Art Unit: 2814

Filed: December 17, 2003

Examiner: D. NGUYEN

For: SEMICONDUCTOR DEVICE

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AMENDMENT AFTER FINAL REJECTION

M.S. AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed on January 25, 2006, please amend the above-identified patent application as indicated below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.